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## Comparison of Charge Deposition Profiles in Polymers Irradiated With Monoenergetic Electrons: Pulsed Electroacoustic Measurements and AF-NUMIT3 Modeling

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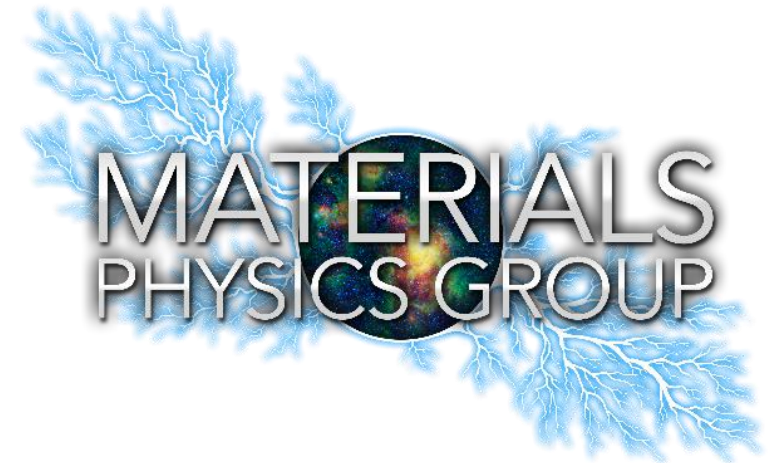


# *Comparison of Charge Deposition Profiles in Polymers Irradiated with Monoenergetic Electrons: Pulsed Electroacoustic Measurements and AF-NUMIT3 Modeling*

**Zachary Gibson,<sup>1</sup> JR Dennison,<sup>1</sup> and Brian Beecken<sup>2</sup>**

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# Overview

- Goals and Importance
- Simulations: AF-NUMIT3
- Measurements: Pulsed Electroacoustic Method
- Experiment
- Results
- Conclusions
- Future Work

# Goals and Importance

## **Goals:**

- Investigate spacecraft charging
- Improve deep dielectric charging predictions (AF-NUMIT3)
- Validate our PEA system

## ***Why?***

- Better modeling and experimentation allow for more accurate determination of deep dielectric charging and predictions of catastrophic breakdown in dielectric materials

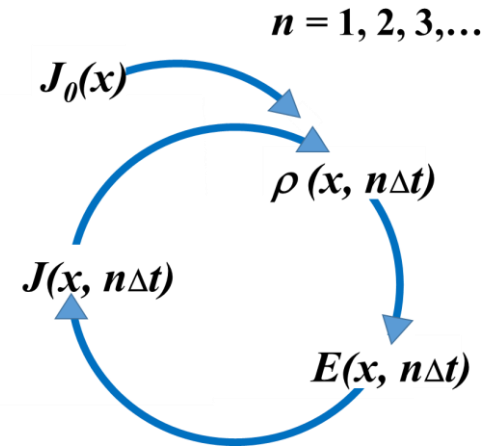
# Simulation of Charge Deposition: AF-NUMIT3

## I. What is AF-NUMIT3?

- **NUMIT = Numerical Iteration**
- Goal: predict dangerously high Electric Fields within dielectric
- Simulation (1D) of charge build-up and transport deep in dielectric
- Material Input parameters: thickness, effective atomic number and weight, density, relative permittivity, dark conductivity, RIC coefficients

## II. Simulation Steps for NUMIT

- 1) Input Electron Flux Spectra (time dependent!)
- 2) Determine Deposition Profile of incident Charge and Energy
  - Charge required to determine Electric Field
  - Energy required to determine Radiation Induced Conductivity (RIC)
- 3) Model charge transport using electrodynamics and material characteristics



Continuity Eq.  $\frac{\partial J(x, t)}{\partial x} = -\frac{\partial \rho(x, t)}{\partial t}$

Gauss's Law  $\frac{\partial E(x, t)}{\partial x} = \frac{\rho(x, t)}{\epsilon}$

- Dielectric is divided into ~ 1000 spatial bins
- As incident electron current decreases with depth charge is deposited in bins
- **Algorithms** required for  $J_0(x)$  and  $\dot{D}(x)$

Total Current Eq.  
(Fowler Model)

$$J(x, t) = J_0(x) + [g_0 + k\dot{D}(x)] E(x, t),$$

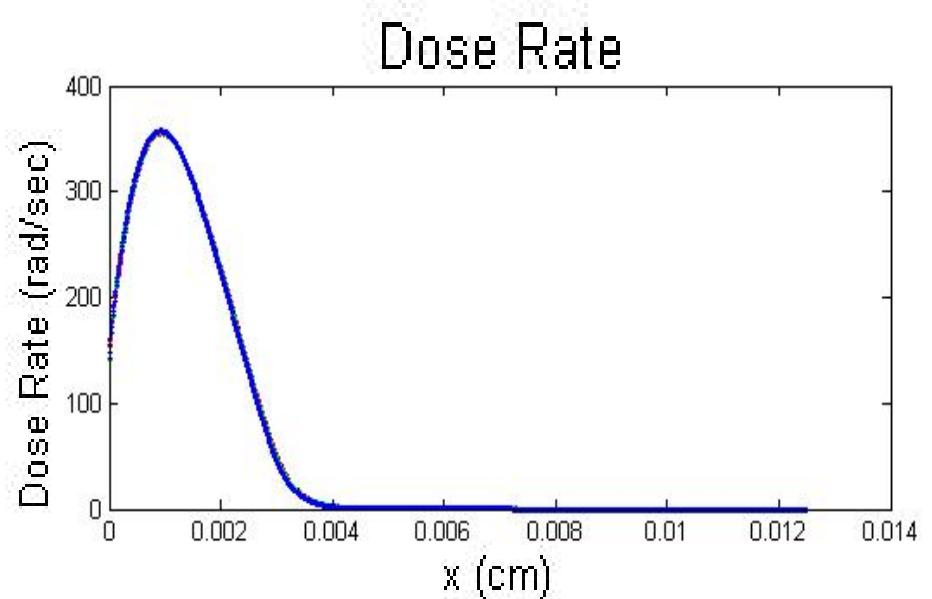
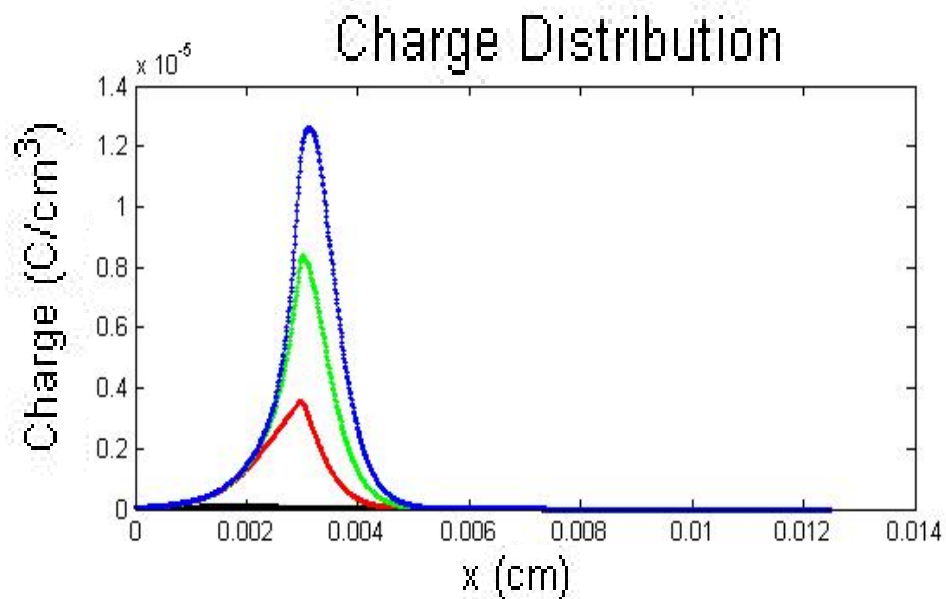
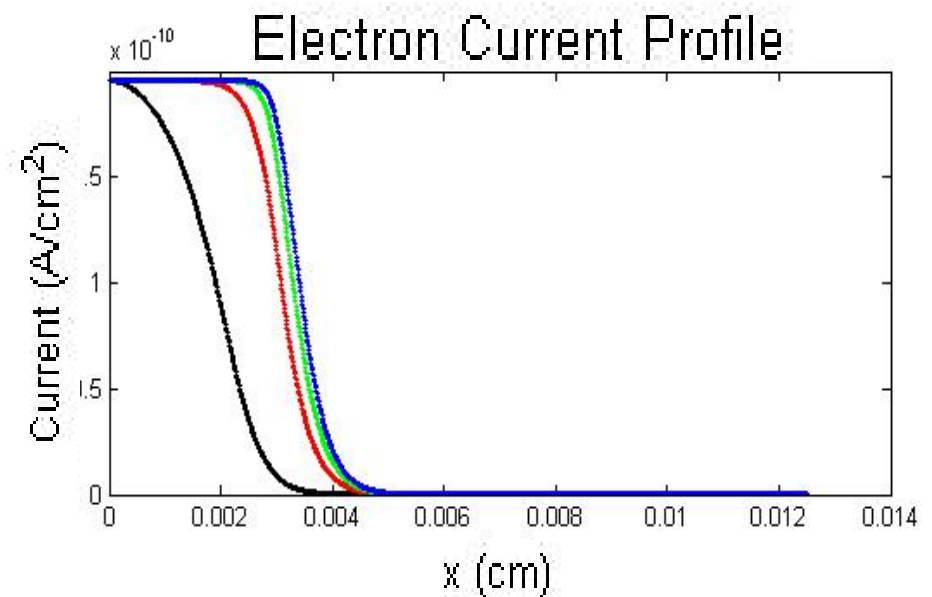
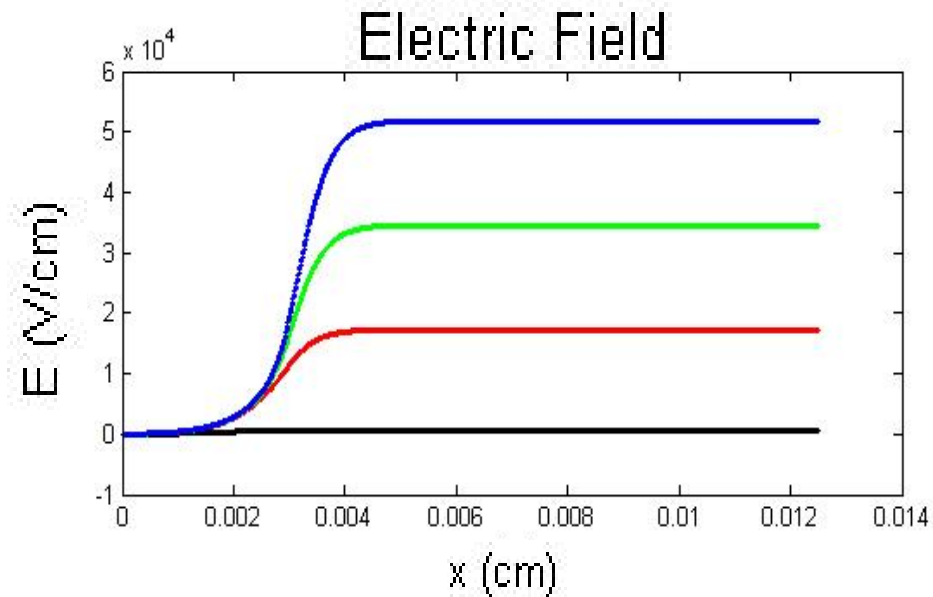
Incident  
Electron Current

Dark  
Conductivity

Coef. of  
RIC

Dose  
Rate

# AF-NUMIT3 Sample Output



# The Experimental Set-up: What is PEA?

## How it works:

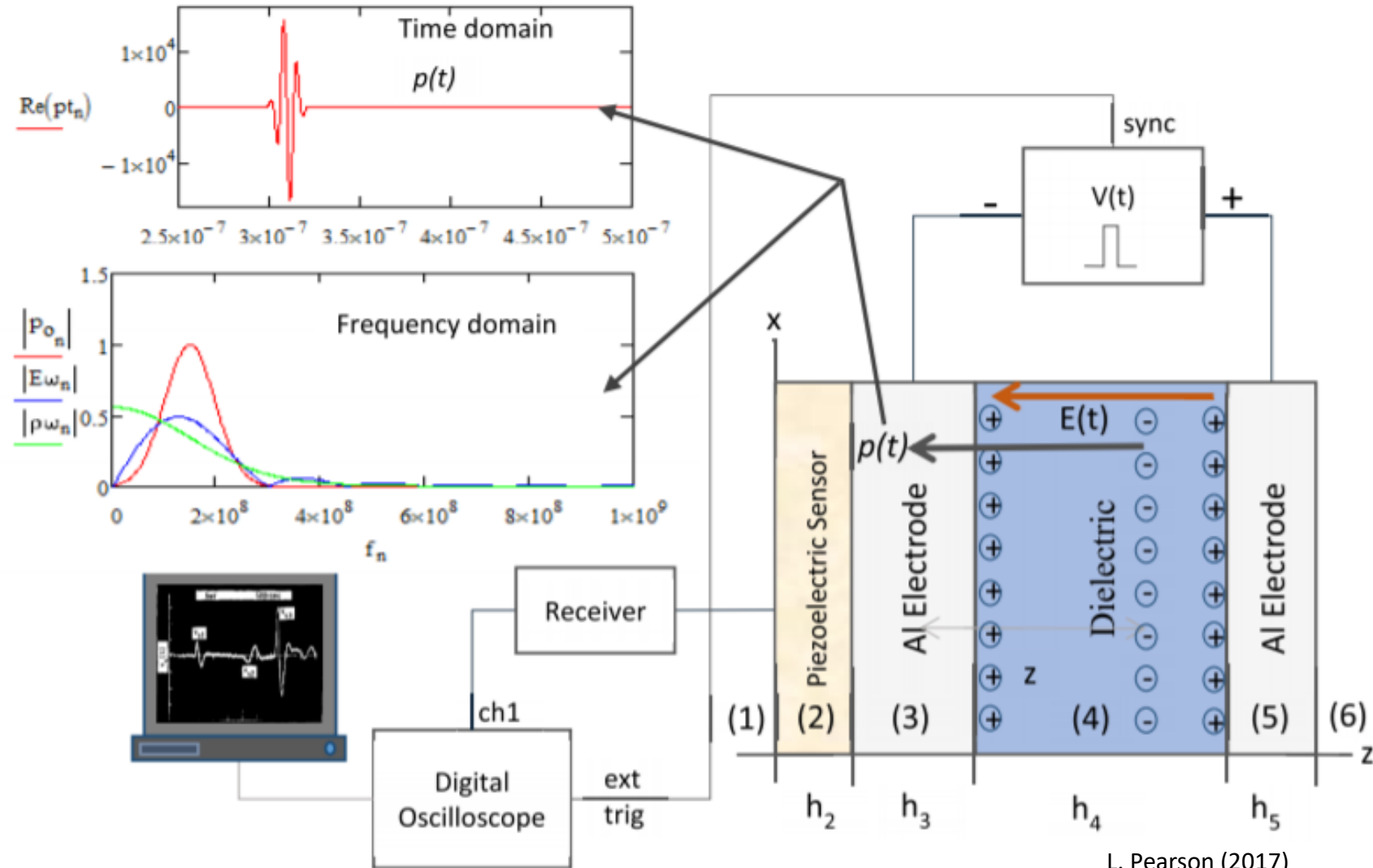
- Pulsed voltage probes embedded charge
- Time of flight indicates position of charge

## Benefits:

- Nondestructive measurement
- Low cost

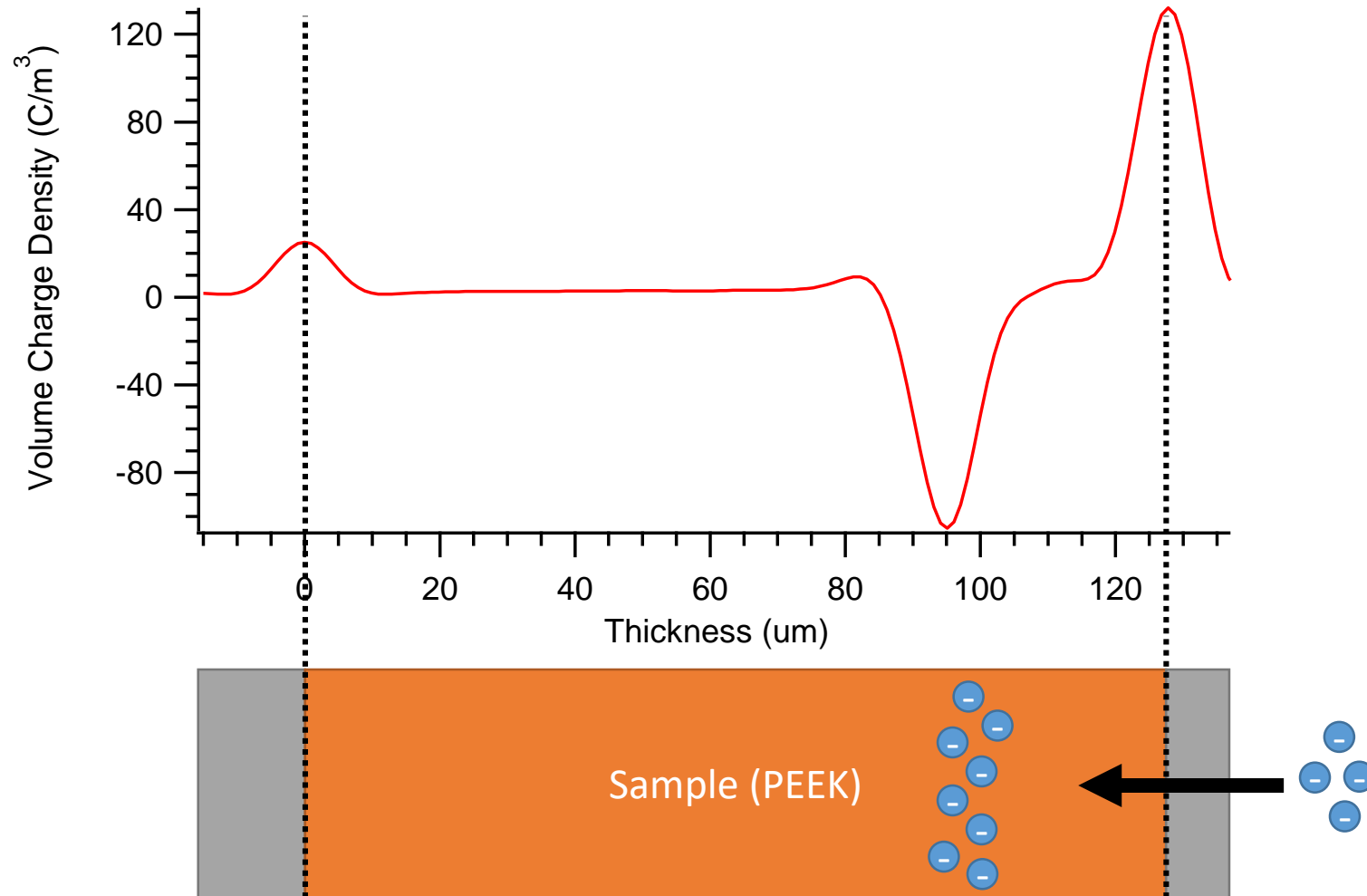
## Limitations:

- Hard to increase resolution
  - High cost electronics
  - Difficult sensor fabrication



L. Pearson (2017)

# Measuring Charge Distributions – An Example





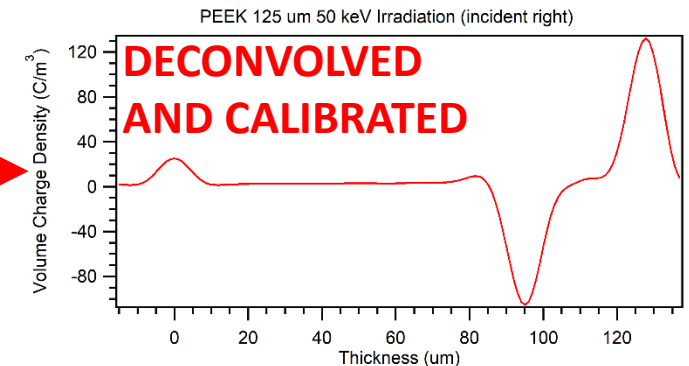
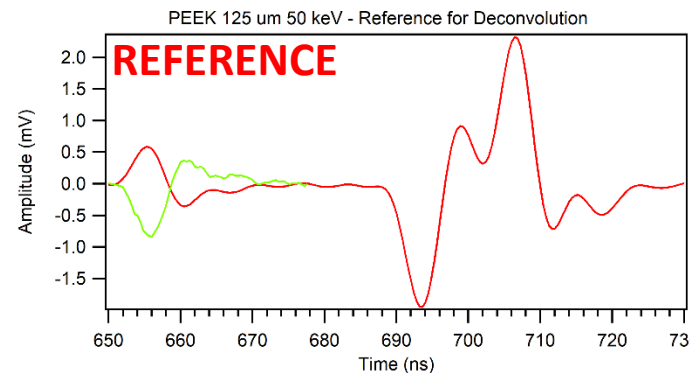
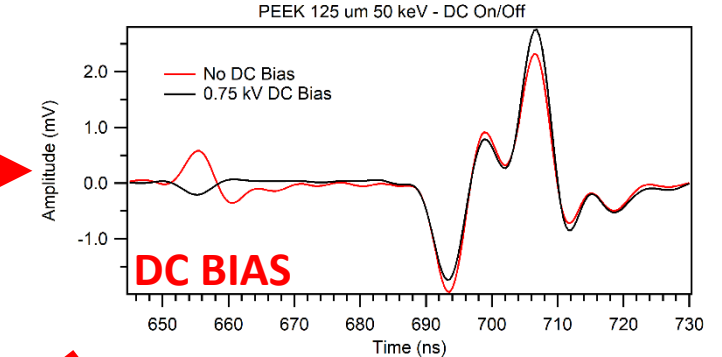
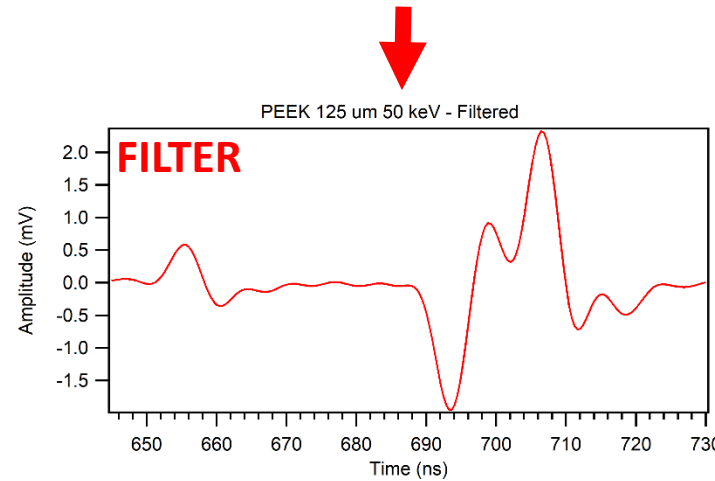
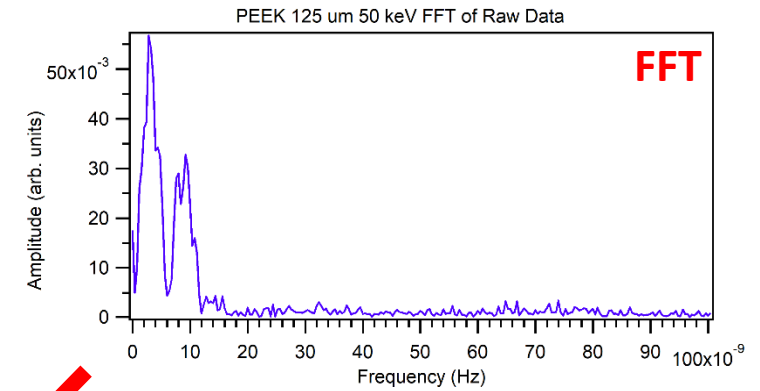
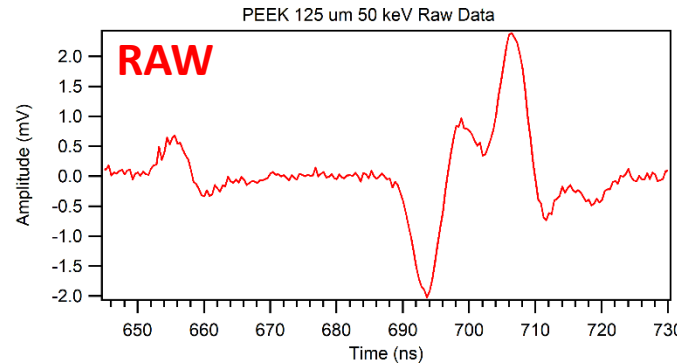
# Signal Processing

## Processing Steps:

- Average multiple measurements and compute statistics (not shown)
  - The rest of the processing is done on the averaged measurement
- Compute FFT to determine filter parameters
- Modified Gaussian filter used on data
- Take difference of DC on – DC off to obtain reference wave
  - Refer to (Chen 2006)
- Use system response to perform deconvolution

## Calibration

- Multiply by calibration factor
  - $Calibration\ Factor = \frac{\epsilon_r \epsilon_o V_{DC}}{d \int V_{Ref} Signal dx}$
- Calibrate x-axis to distance using the speed of sound calculated from the measured thickness and peak-to-peak time difference of the two interfaces



# Electron Irradiation of Polymers

## Goals:

Simulate deposited charge via AF-NUMIT3  
Measure deposited charge via PEA method  
Compare the results

## Experiment:

### Samples

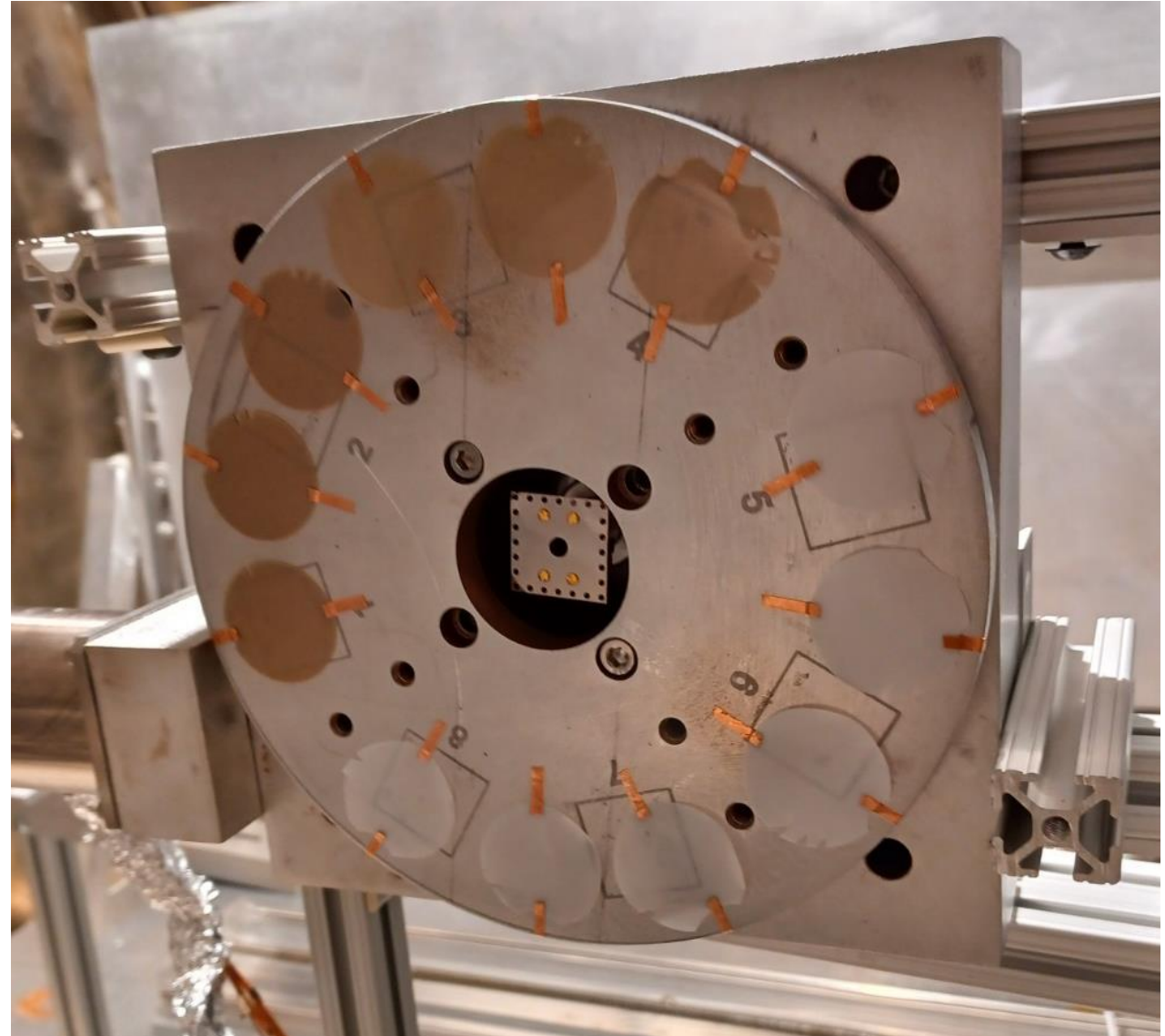
- Polyether-etherketone (PEEK)
- Polytetrafluoroethylene (PTFE)

### Thicknesses

- 125  $\mu\text{m}$
- 250  $\mu\text{m}$

### Irradiation Energy

- 50 keV
- 80 keV



# The Experiment – Irradiation Details

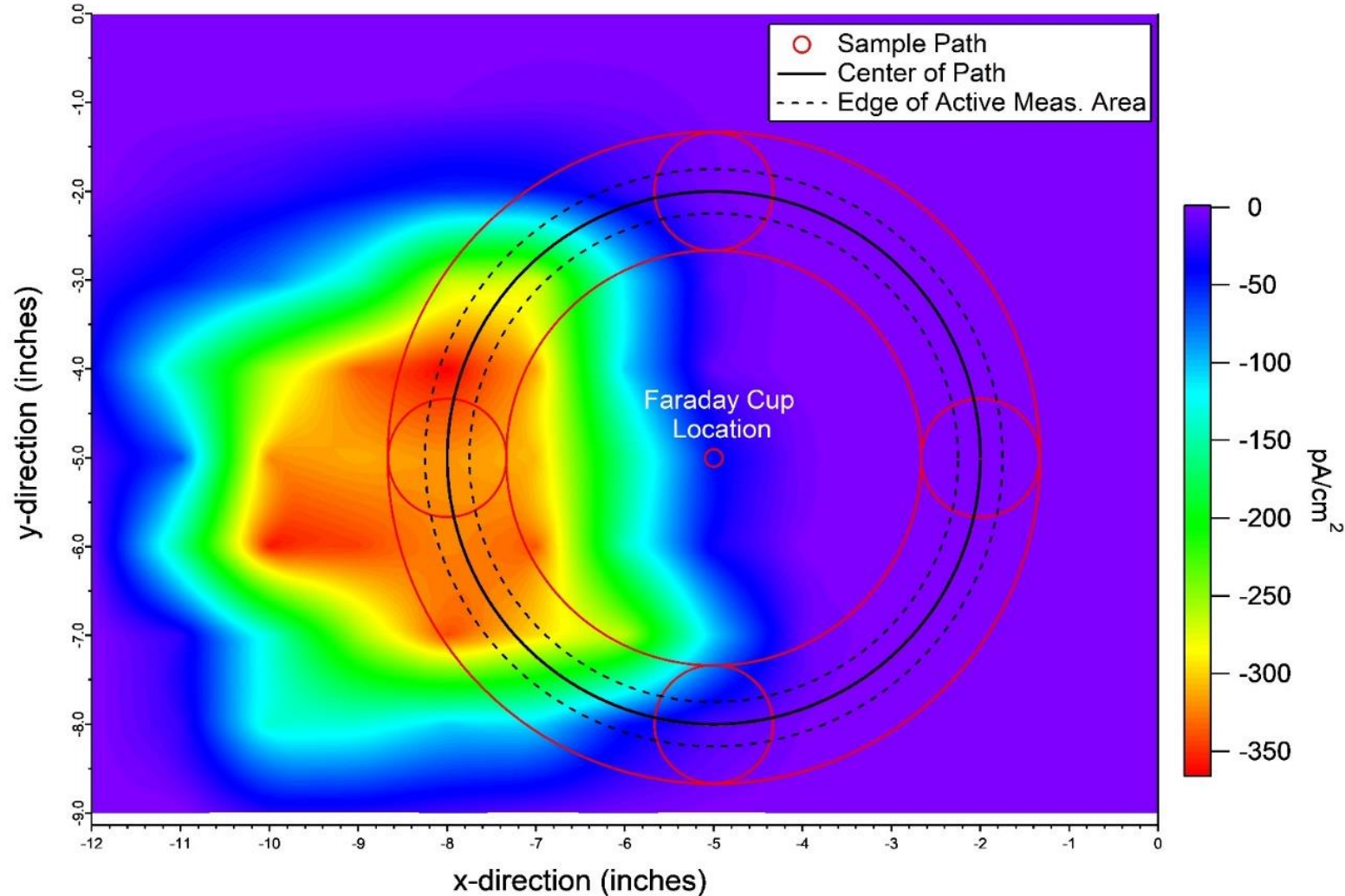
## Average Flux

- For 80 keV, 210 pA/cm<sup>2</sup>
- For 50 keV, 220 pA/cm<sup>2</sup>

## Irradiation time

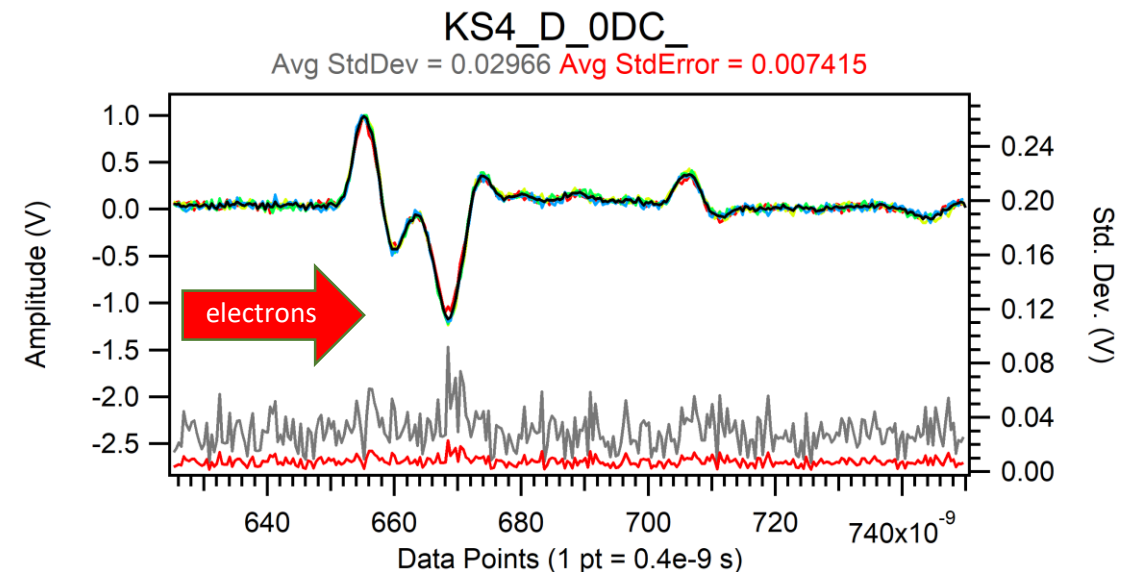
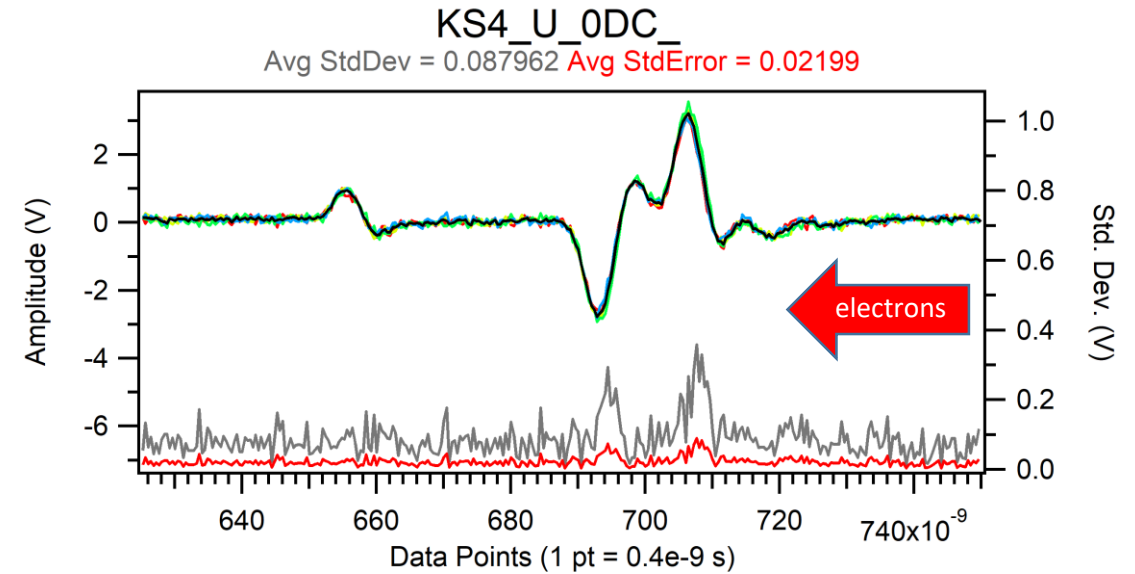
- 150 s
- 75 s in beam
- 75 s out of beam
- 30 s per rotation (2 RPM)

Beam Profile with Sample Path (80 keV; FC = 42.5 pA/cm<sup>2</sup>)



# Typical Raw PEEK Measurement

- Low attenuation
- Low dispersion
- Deconvolution of this dataset is straightforward
- Calibration of data is straightforward



# Results: PEEK 125 $\mu\text{m}$ at 50 keV

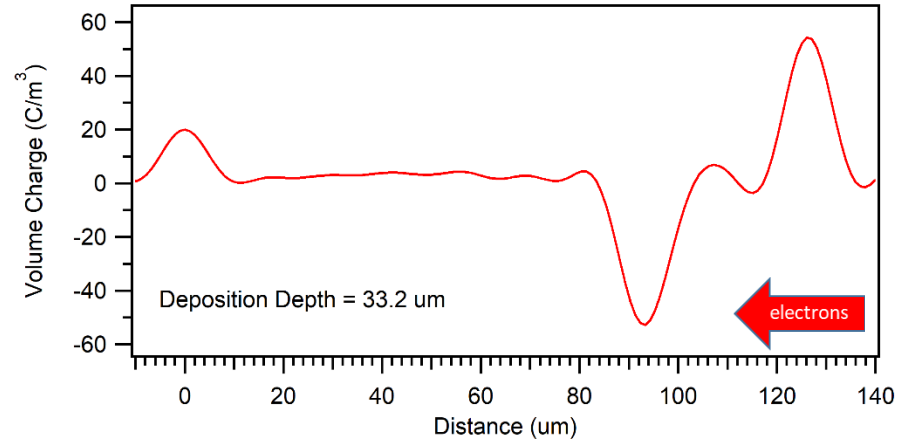
125  $\mu\text{m}$  PEEK 50 keV - Incident Left (Sample #4)

**Measured:  $33 \pm 0.5 \mu\text{m}$**

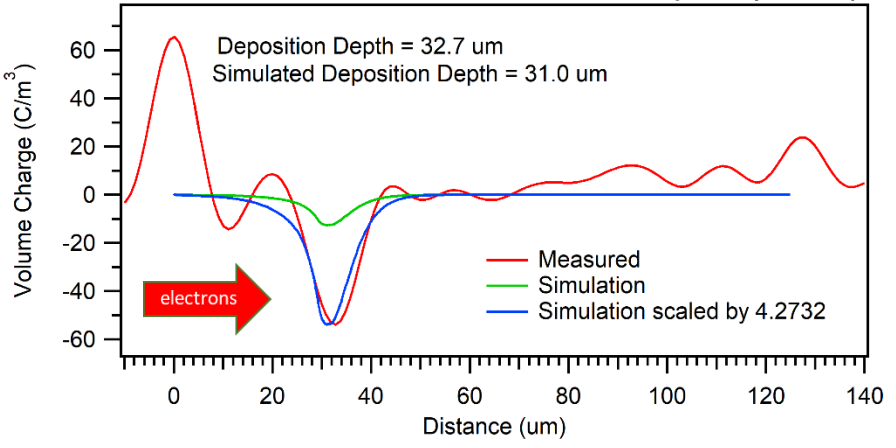
**Simulated:  $31 \mu\text{m}$**



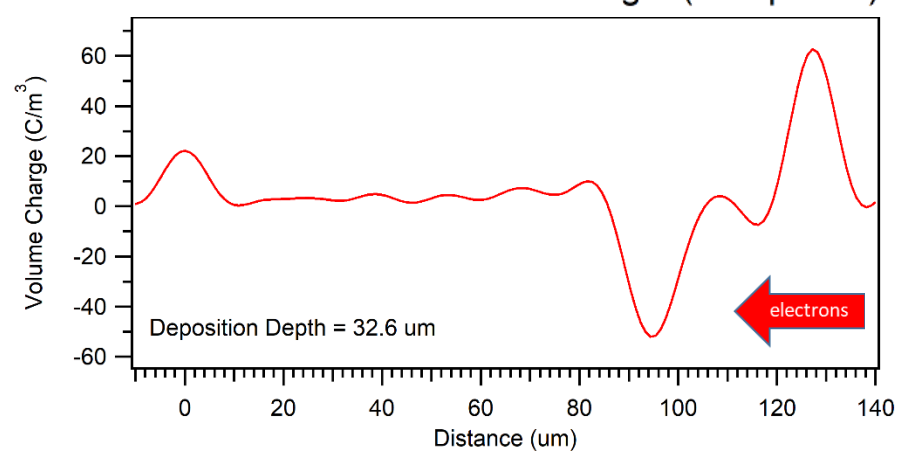
125  $\mu\text{m}$  PEEK 50 keV - Incident Right (Sample #4)



125  $\mu\text{m}$  PEEK 50 keV - Incident Left (Sample #6)



125  $\mu\text{m}$  PEEK 50 keV - Incident Right (Sample #6)

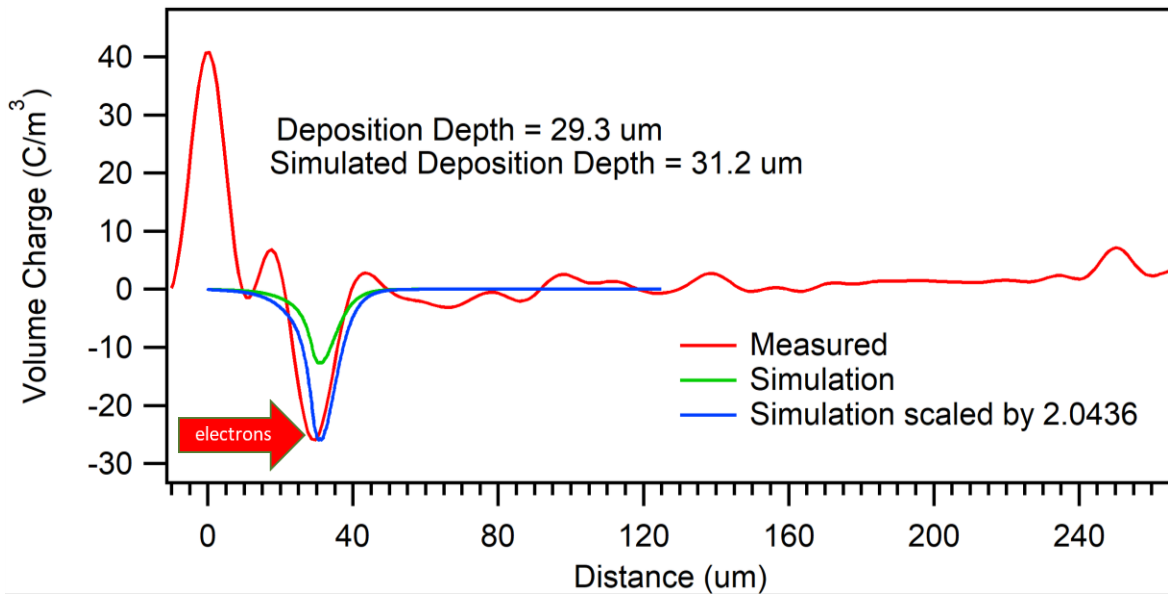


**Measured:  $33 \pm 0.5 \mu\text{m}$**

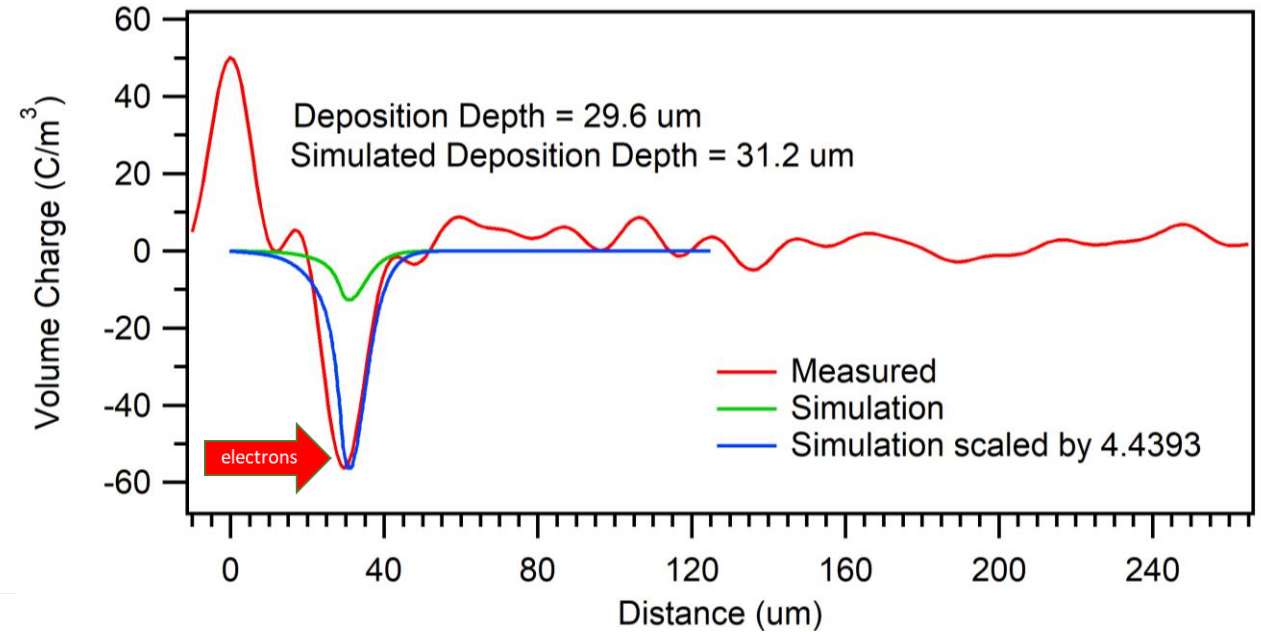
**Simulated:  $31 \mu\text{m}$**

# Results: PEEK 250 $\mu\text{m}$ at 50 keV

PEEK 250  $\mu\text{m}$  - 50 keV Incident Left (Sample #4)



PEEK 250  $\mu\text{m}$  - 50 keV Incident Right (Sample #6)

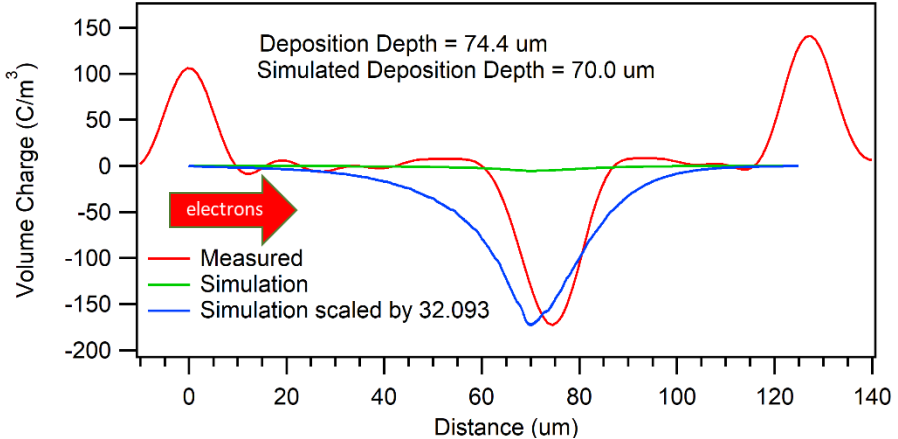


**Measured:  $29.5 \pm 0.5 \mu\text{m}$**

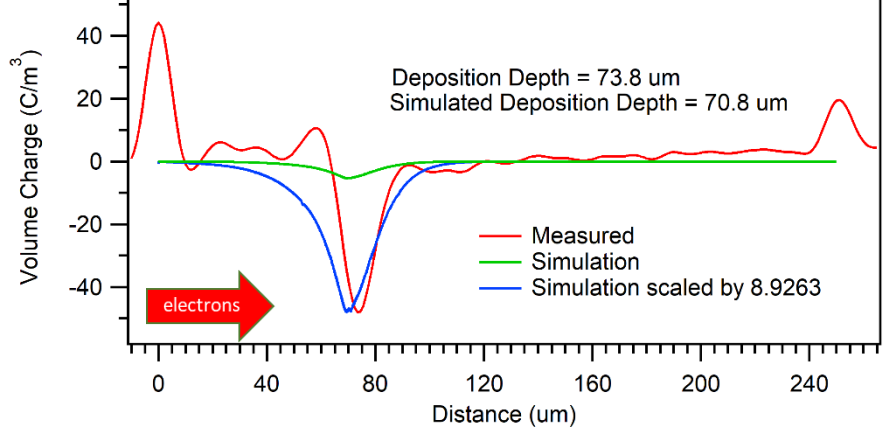
**Simulated: 31.2  $\mu\text{m}$**

# Results: PEEK 125 and 250 $\mu\text{m}$ at 80 keV

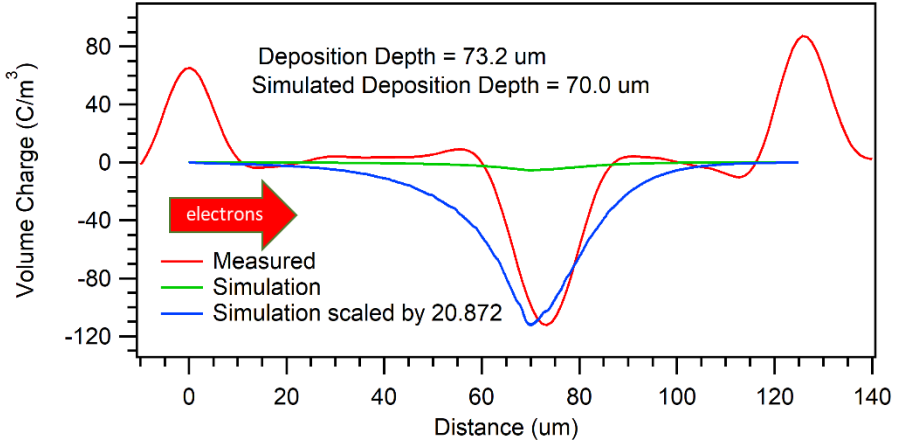
125  $\mu\text{m}$  PEEK - 80 keV Incident Left (Sample #1)



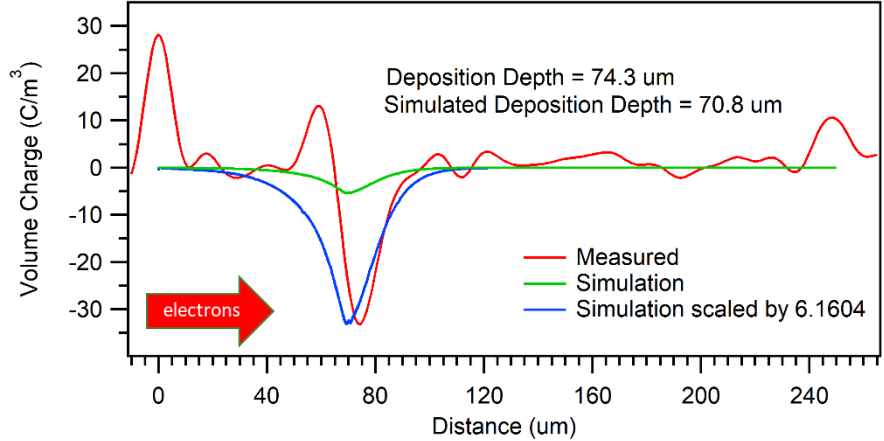
250  $\mu\text{m}$  PEEK - 80 keV Incident Left (Sample #1)



125  $\mu\text{m}$  PEEK - 80 keV Incident Left (Sample #3)



250  $\mu\text{m}$  PEEK - 80 keV Incident Left (Sample #3)

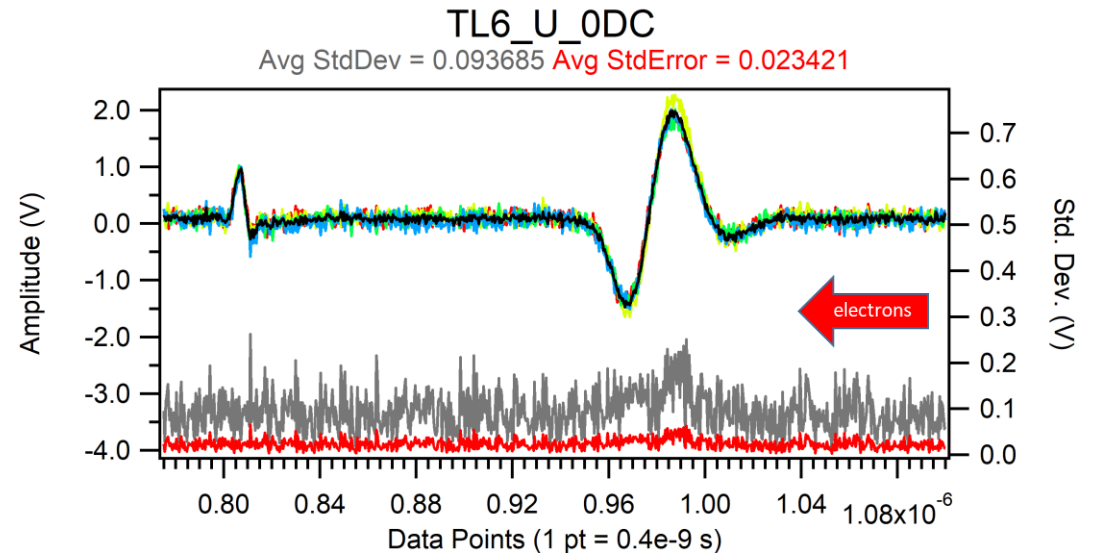
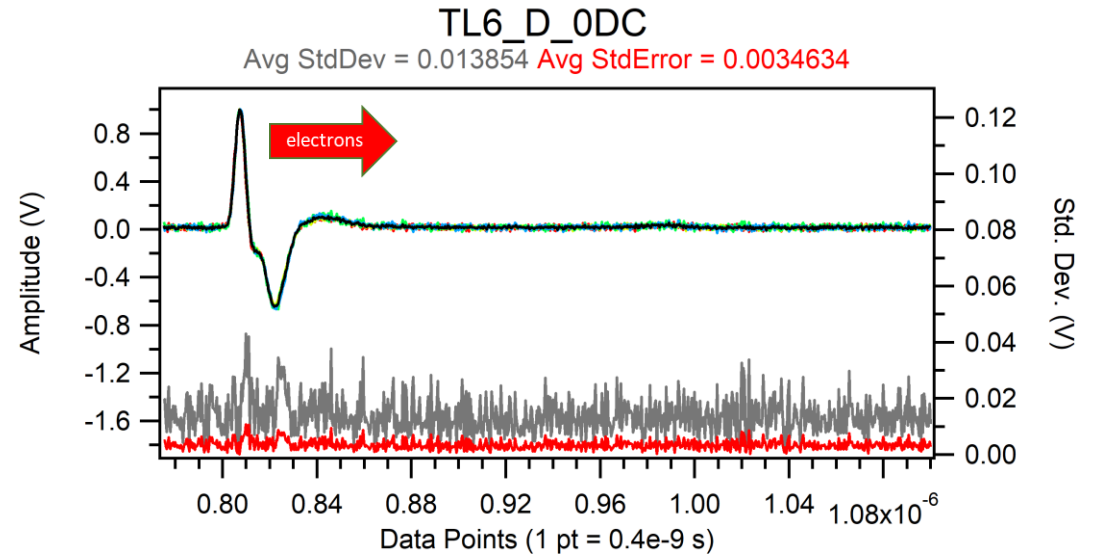


**Measured:  $74 \pm 1 \mu\text{m}$**   
**Simulated:  $70 \mu\text{m}$**

**Measured:  $74 \pm 0.5 \mu\text{m}$**   
**Simulated:  $70.8 \mu\text{m}$**

# Typical Raw PTFE Measurement

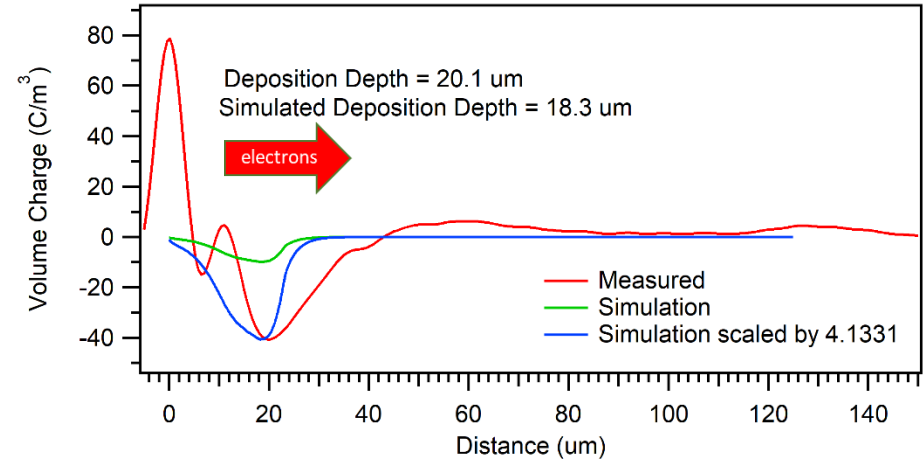
- Strong attenuation
- Strong dispersion
- Deconvolutions do not work as well on this dataset
- Calibration of data is difficult



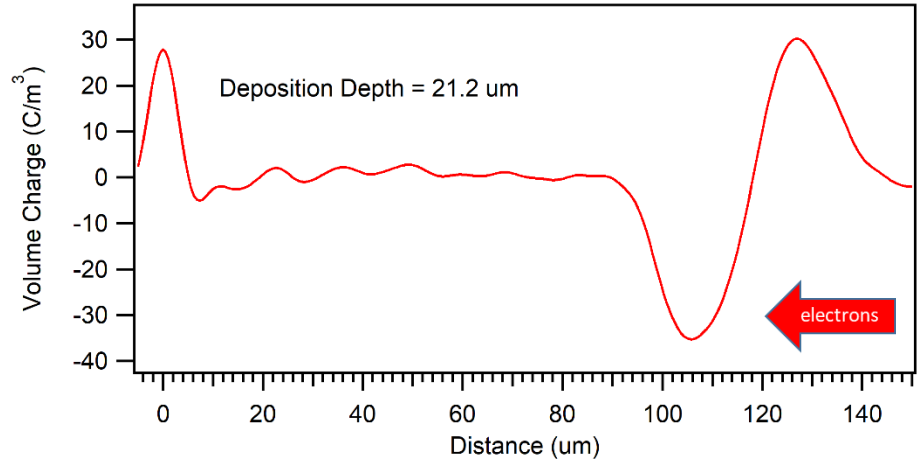


# Results: PTFE 125 $\mu\text{m}$ at 50 keV

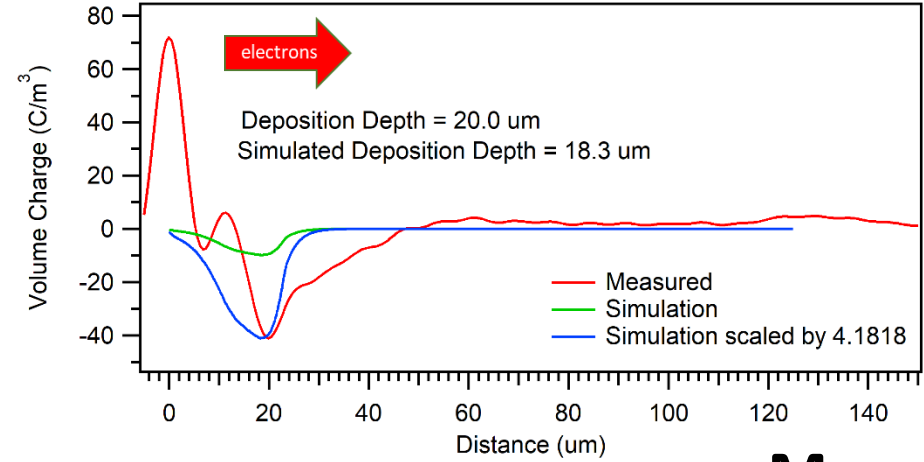
125  $\mu\text{m}$  PTFE - 50 keV Incident Left (Sample #4)



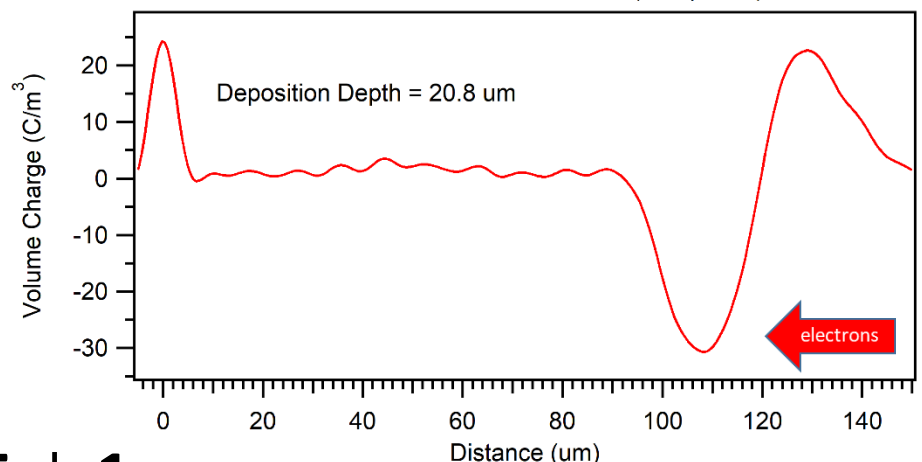
125  $\mu\text{m}$  PTFE - 50 keV Incident Right (Sample #4)



125  $\mu\text{m}$  PTFE - 50 keV Incident Left (Sample #6)



125  $\mu\text{m}$  PTFE - 50 keV Incident Right (Sample #6)

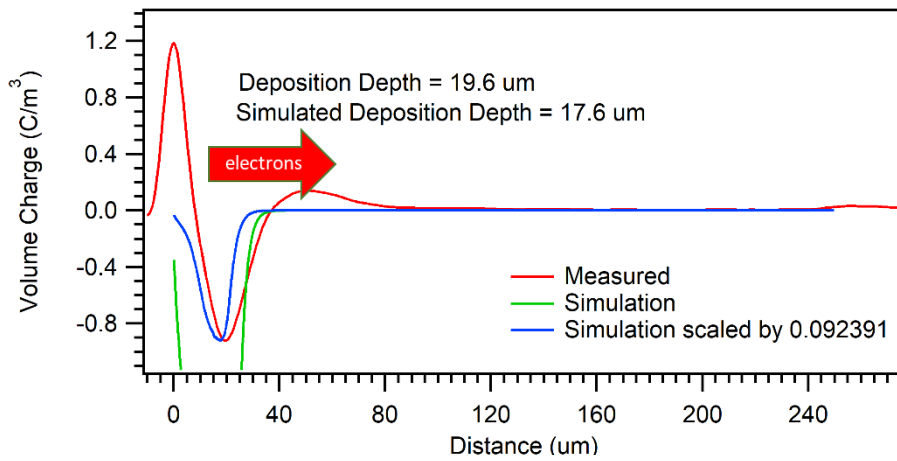


**Measured:  $20.5 \pm 1 \mu\text{m}$**

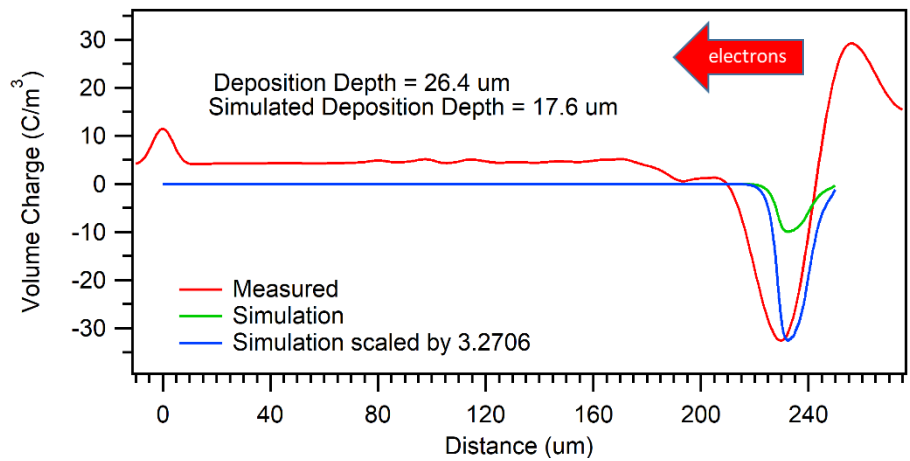
**Simulated: 18  $\mu\text{m}$**

# Results: PTFE 250 $\mu\text{m}$ at 50 keV

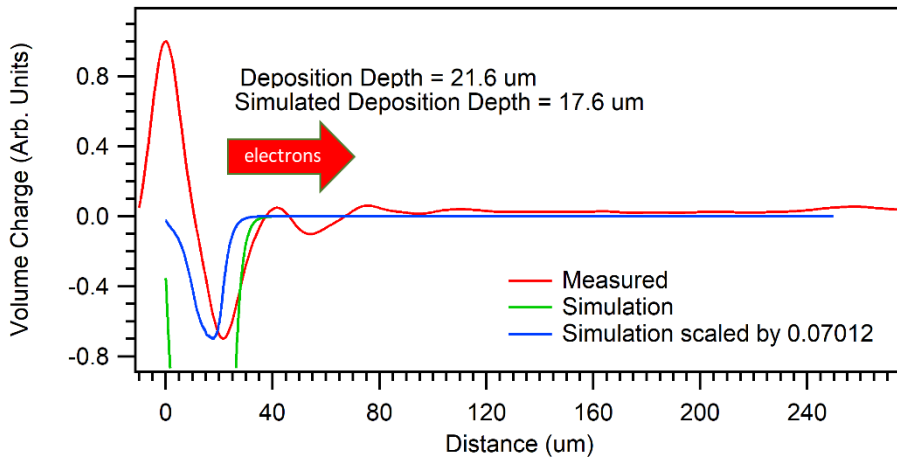
250  $\mu\text{m}$  PTFE - 50 keV Incident Left (Sample #4)



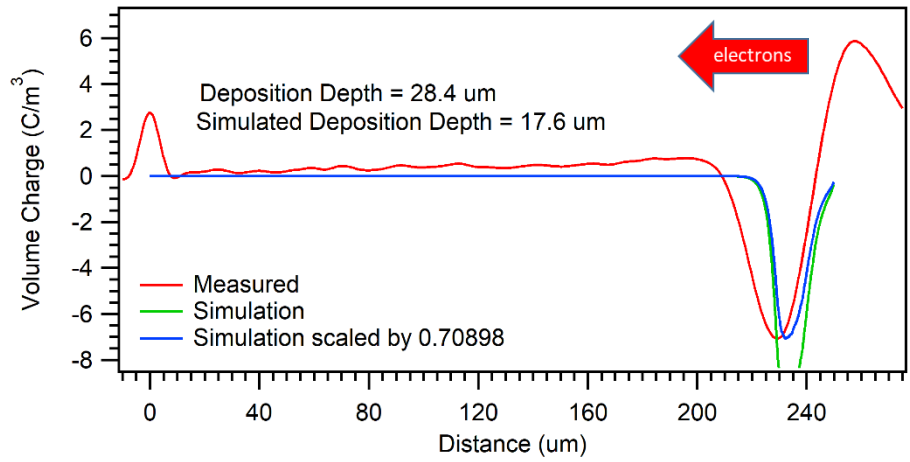
250  $\mu\text{m}$  PTFE - 50 keV Incident Right (Sample #4)



250  $\mu\text{m}$  PTFE - 50 keV Incident Left (Sample #6)



250  $\mu\text{m}$  PTFE - 50 keV Incident Right (Sample #6)



**Measured:  $20 \pm 2 \mu\text{m}$**

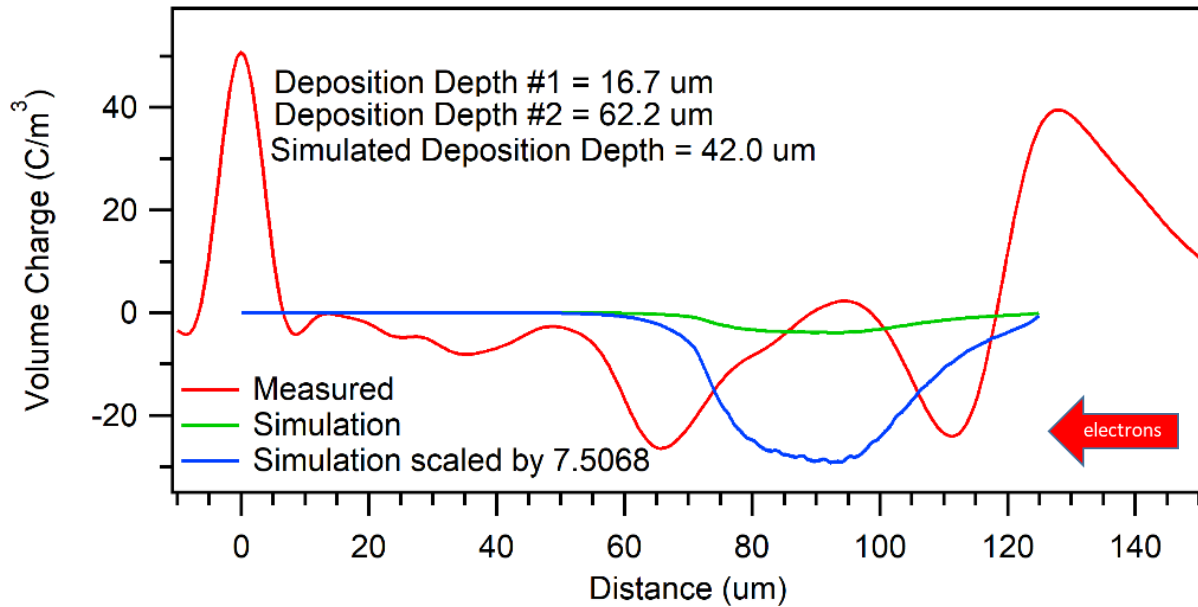
**Simulated:  $17.6 \mu\text{m}$**

**Measured:  $27 \pm 3 \mu\text{m}$**

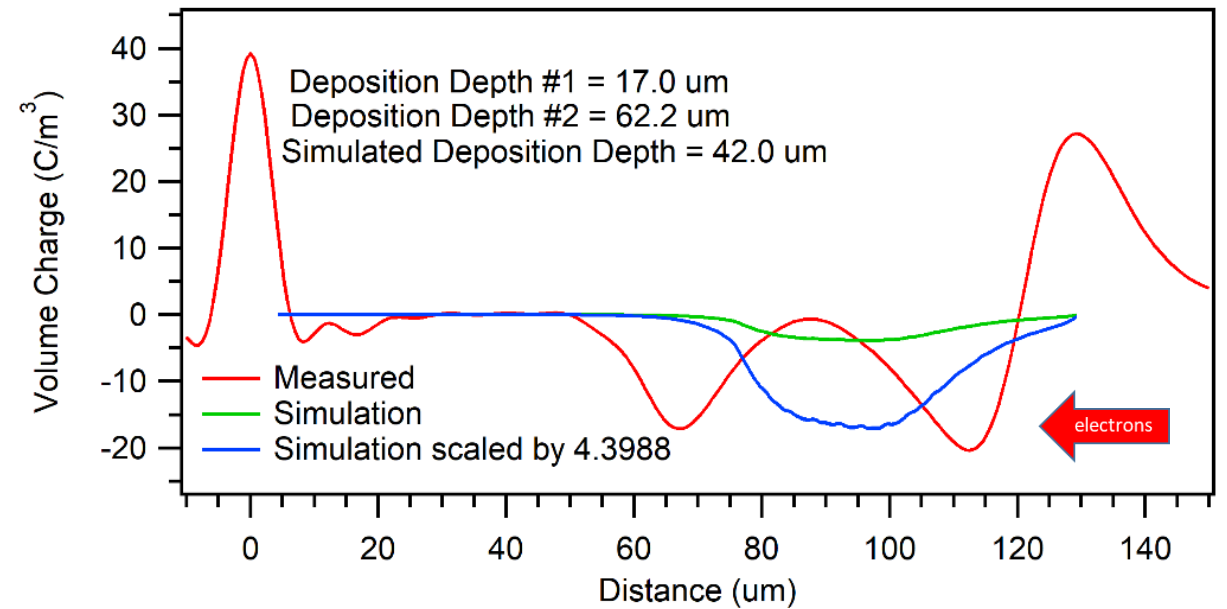
**Simulated:  $17.6 \mu\text{m}$**

# Results: PTFE 125 $\mu\text{m}$ at 80 keV

125  $\mu\text{m}$  PTFE - 80 keV Incident Right (Sample #1)



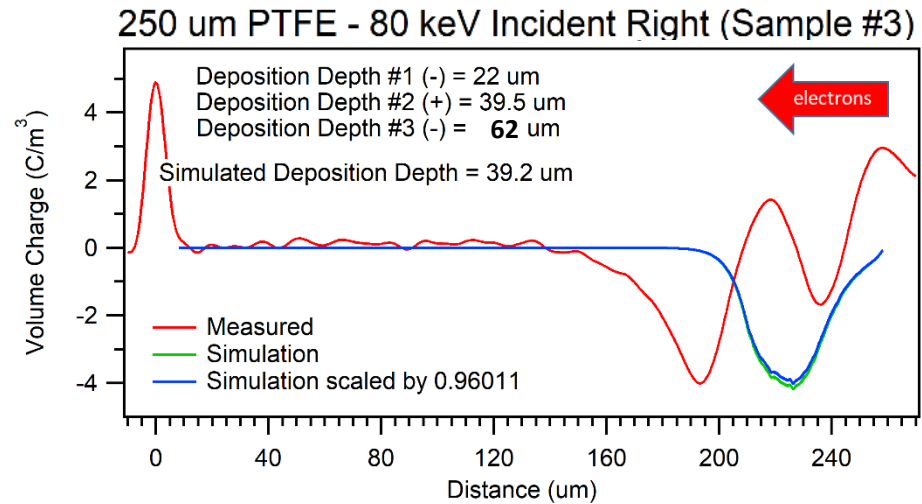
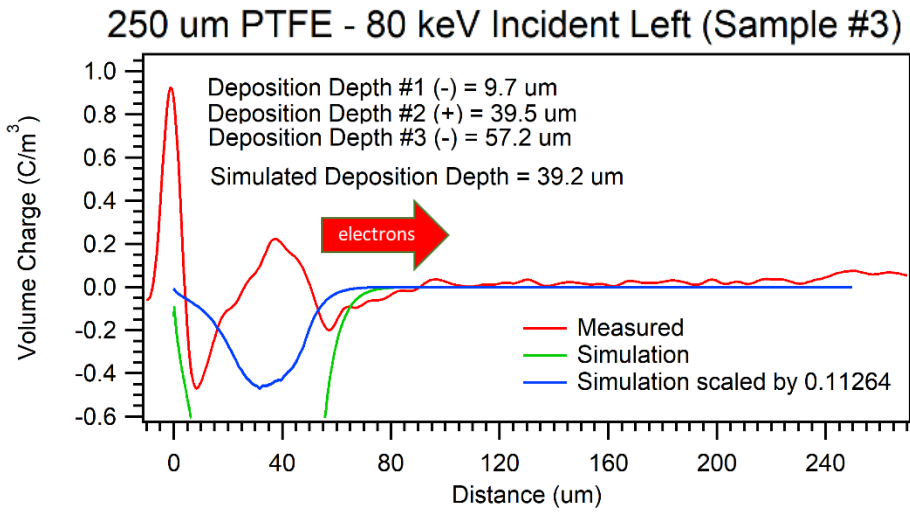
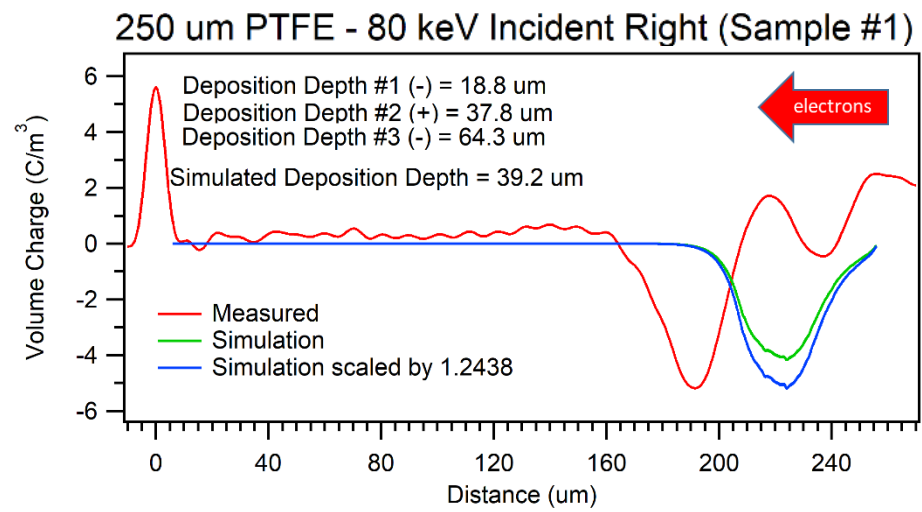
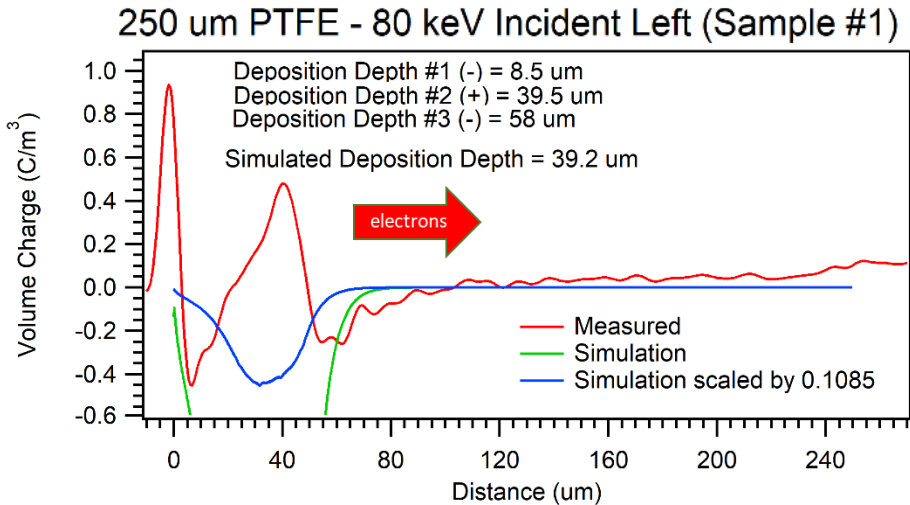
125 PTFE  $\mu\text{m}$  - 80 keV Incident Right (Sample #3)



**Measured:  $17 \pm 0.5 \mu\text{m}$  and  $62 \pm 0.5 \mu\text{m}$**

**Simulated: 42  $\mu\text{m}$**

# Results: PTFE 250 $\mu\text{m}$ at 80 keV



**Measured: 9(-), 40 (+), and 58 (-)  $\mu\text{m}$**   
**Simulated: 39.2  $\mu\text{m}$**

**Measured: 20(-), 38 (+), and 63 (-)  $\mu\text{m}$**   
**Simulated: 39.2  $\mu\text{m}$**

# Conclusions

## PEEK

- Measurements are self-consistent for a given sample when comparing orientations of measurements
- Measurements are mostly consistent with samples exposed to similar environments
- Measurements agree fairly well with predicted deposition depths from AF-NUMIT3
- Experimental deviations in deposition depths needs to be investigated to be sure this is “real” and not within error

## PTFE

- Data is not always self-consistent for a given sample, varying by several or tens of microns between measurements in different orientations
- Multiple peaks were measured in 80 keV irradiated samples
- AF-NUMIT3 predicted a single peak in between the measured peaks for 80 keV irradiated samples
- Deposition depths for 50 keV irradiated samples were in relatively good agreement with simulations from AF-NUMIT3

## Overall

- Attenuation and dispersion needs to be corrected for in the data
- More work is needed in determining the absolute error of the magnitude of charge measured
- AF-NUMIT3 agrees fairly well with the data, aside from the multiple peaks in PTFE irradiated at 80 keV

# Future Work

- Determine error and validity of the calibration of the charge magnitude in PEA measurements
- Correct for attenuation and dispersion in PEA measurements
- Investigate effects of RIC/DRIC on charge accumulation and migration
  - AF-NUMIT3 predicts differences between no RIC/RIC/DRIC simulations
  - Accumulation of charge from pulsed/continuous beam and low/high dose rate
- Address relative and absolute errors in PEA measurements for insight into differences in deposition depths between measurements/different samples
  - Differentiation resolution appears to be  $\sim 0.5 \mu\text{m}$  or less

## Acknowledgements

- Thanks to Ryan Hoffmann and the Space Vehicle Directorate at the Air Force Research Lab for irradiating our samples

## References

- Pearson, L. H., Dennison, J. R., Griffiths, E. W., & Pearson, A. C. (2017). PEA System Modeling and Signal Processing for Measurement of Volume Charge Distributions in Thin Dielectric Films. *IEEE Transactions on Plasma Science*, 45(8), 1955-1964. doi:10.1109/tps.2016.2632627
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- Vazquez, A., Chen, G., Davies, A., & Bosch, R. (1999). Space charge measurement using pulsed electroacoustic technique and signal recovery. *Journal of the European Ceramic Society*, 19(6-7), 1219-1222.